

FORM PTO-1449	SERIAL NO.	CASE NO.
RADEN	09/832,645	9333/267
LIST OF PATENTS AND PUBLICATIONS FOR	FILING DATE	GROUP ART UNIT
APPLICANT'S INFORMATION DISCLOSURE	April 11, 2001	2626
STATEMENT		
(use several sheets if necessary)	APPLICANT(S): Koulchi Satoh	

REFERENCE DESIGNATION			U.S. PATENT DO	CUMENTS		
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER		DOCUMENT			CLASS/	TRANSL	ATION
INITIAL		NUMBER	DATE	COUNTRY	SUBCLASS	YES	NO
7W	C1	H06-073800	03/15/1994	Japan		Х	
70	C2	H11-219105	08/10/1999	Japan		X	
JW	C3	2000-089776	03/31/2000	Japan		Х	
JW	C4	H11-288296	10/19/1999	Japan		X	
50	C5	H06-243391	09/02/1994	Japan		X	

EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER	This	DATE CONSIDERED	9/12/06	

EXAMPLER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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EXAMINER | DOCUMENT | DATE | COUNTRY | SUBCLASS | TRANSLATION | YES | NO |

EXAMINER INITIAL		OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)
JW	D1	(Corresponding) Japanese Patent Application No. 2000-114244 Office Action dated July 10, 2006
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EXAMINER	why	DATE CONSIDERED	101	19	106	•
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